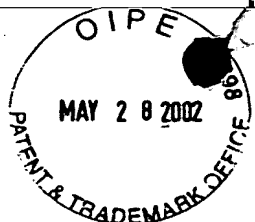


214183US2



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

Yoshihiro MINAMI

SERIAL NO.: 09/960,333

FILED: September 24, 2001

FOR: SPIRAL INDUCTOR AND  
METHOD FOR FABRICATING  
SEMICONDUCTOR  
INTEGRATED CIRCUIT  
DEVICE HAVING SAME

:

: EXAMINER: MANDALA, V.

:

: GROUP ART UNIT: 2826

:

#15  
Elected  
RECEIVED  
MAY 29 2002  
TC 2800 MAIL ROOM

AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

SIR:

Prior to further consideration of the above-identified application, please amend the application as follows:

IN THE TITLE

At page 1, lines 1-2, please delete the title in its entirety and substitute therefor:

SEMICONDUCTOR DEVICE WITH SPIRAL INDUCTOR AND METHOD FOR  
FABRICATING SEMICONDUCTOR INTEGRATED CIRCUIT DEVICE